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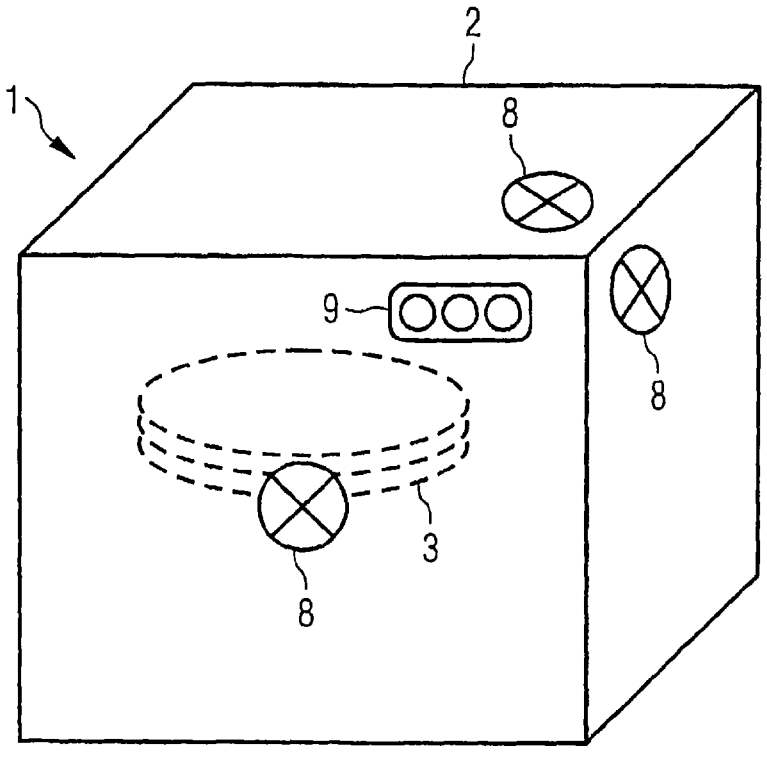
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(54) Title: SEMICONDUCTOR PRODUCT CONTAINER AND EQUIPMENT FOR HANDLING A SEMICONDUCTOR PRODUCT CONTAINER



(57) Abstract: Disclosed is an equipment for handling a semiconductor product container (2), the equipment comprising handling means (14) for transporting and positioning the container, wherein a loading/unloading position requires first support members forming part of a loading/unloading device engaging with second support members forming part of the container. According to the invention, the equipment comprises detection means (15) for detecting reference point positions of the container and localization means (16) for computing the position of the container from the detected reference point positions, and allows for handling the containers without the need of mounting any support pins on each storage location in prior art.

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